
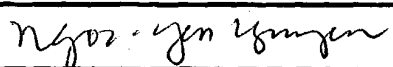


INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number		10/038,745	
		Filing Date		January 2, 2002	
		First Named Inventor		Robert Jackson	
		Group Art Unit		1754	
		Examiner Name		Ngoc Nguyen	
Sheet 1 of 1		Attorney Ref. Number		FOC1100-1	
NON-PATENT LITERATURE DOCUMENTS					
		C6	International Search Report for PCT/US02/37912 mailed July 23, 2003.		
Examiner Signature				Date Considered	12/09/04

on
RECEIVED
AUG 12 2004
GROUP 1705

FORM PTO 1449 US Department of Commerce
Patent and Trademark Office

ATTY DOCKET NO.:

FOC1100-1

SERIAL NO.:

10/038,745

**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT**

APPLICANT(S):

Robert Jackson

FILING DATE:

January 2, 2002

GROUP ART. UNIT:

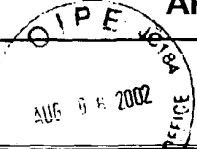
1754

PATENT NO. OF PARENT:

n/a

ISSUE DATE OF PARENT:

n/a



U.S. PATENT DOCUMENTS

EXAM. INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<i>sm</i>	A24	2,879,212	Hill, et al.	204	60	12/19/55
	A25	3,146,179	Davies	204	60	03/15/62
	A26	3,684,667	Sayce	204	60	07/27/70
	A27	4,125,443	Grant, et al.	204	60	09/29/77
	A28	4,176,018	Faron, et al.	204	60	11/03/78
	A29	4,312,718	Watanabe, et al.	204	60	06/20/80
	A30	4,900,395	Syverson, et al.	156	639	04/07/89
	A31	4,960,488	Law, et al.	156	643	12/19/89
	A32	5,002,632	Loewenstein, et al.	156	643	11/22/89
	A33	5,298,112	Hayasaka, et al.	156	643	12/15/92
	A34	5,378,324	Hodgson	204	60	04/02/93
	A35	5,405,491	Shahvandi, et al.	156	643	03/04/94
	A36	5,597,495	Keil, et al.	216	66	11/07/94
	A37	5,705,080	Leung, et al.	216	67	07/06/94
	A38	5,762,813	Takiyama, et al.	216	67	03/13/96
	A39	5,846,886	Hattori, et al.	438	740	02/28/97
	A40	5,849,639	Molloy, et al.	438	714	11/26/97
<i>sm</i>	A41	5,872,061	Lee, et al.	438	705	10/27/97
	A42	5,880,031	Wong	438	706	06/25/92

EXAMINER

Ngan - Yen Yung

DATE CONSIDERED

12/09/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 US Department of Commerce
Patent and Trademark Office

ATTY DOCKET NO.:

FOC1100-1

SERIAL NO.:

10/038,745

**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT**

APPLICANT(S):

Robert Jackson

FILING DATE:

January 2, 2002

GROUP ART UNIT:

1754

PATENT NO. OF PARENT:

n/a

ISSUE DATE OF PARENT:

n/a

AUG 06 2002

RECEIVED
AUG - 9 2002
TC 1700

<i>yn</i>	A43	5,880,032	03/09/99	Doi, et al.	438	706	07/30/99
<i>yn</i>	A44	5,888,309	03/30/99	Yu	134	1.2	12/29/97
	A45	5,904,566	05/18/99	Tao, et al.	438	689	06/09/97
	A46	5,935,874	08/10/99	Kennard	438	710	03/31/98
	A47	5,970,376	10/19/99	Chen	438	637	12/29/97
	A48	5,980,769	11/09/99	Yanagisawa, et al.	216	67	11/06/97
	A49	6,007,733	12/28/99	Jang, et al.	216	80	05/29/98
	A50	6,024,887	02/15/00	Kuo, et al.	216	48	06/03/97
	A51	6,024,888	02/15/00	Watanabe, et al.	216	73	11/13/96
<i>yn</i>	A52	6,051,505	04/18/00	Chu, et al.	438	710	03/05/98

FOREIGN PATENT DOCUMENTS

EXAM. INITIALS		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES/NO)
	B1						
	B2						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

	C1	
	C2	

EXAMINER

ngor. yun usung

DATE CONSIDERED

12/09/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO 1449 US Department of Commerce
Patent and Trademark Office

ATTY DOCKET NO.:

FOC1100-1

SERIAL NO.:

10/038,745

APPLICANT(S):

Robert Jackson

FILING DATE:

January 2, 2002

GROUP ART UNIT

1754

PATENT NO. OF PARENT:

n/a

ISSUE DATE OF PARENT

n/a

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**



RECEIVED

TC 1700

U.S. PATENT DOCUMENTS

EXAM. INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<i>yn</i>	A1	3,976,447	8/24/76	Merchant, et al.	55	71	3/11/75
	A2	4,960,488	10/2/90	Law, et al.	156	643	12/19/89
	A3	5,207,836	5/4/93	Mei Chang	134	1	6/3/92
	A4	5,336,832	8/9/94	Alfred E. Keller	585	710	11/6/92
	A5	5,549,802	8/27/96	Xin S. Guo	204	298.11	10/24/94
	A6	5,565,038	10/15/96	Ethan Ashley	134	2	5/16/91
	A7	5,685,916	11/11/97	Ye, et al.	134	1.1	7/7/95
	A8	5,756,400	5/26/98	Ye, et al.	438	710	12/8/95
	A9	5,788,778	8/4/98	Shang, et al.	134	1	9/16/96
	A10	5,788,799	8/4/98	Steger, et al.	156	345	6/11/96
	A11	5,844,195	12/1/98	Fairbairn, et al.	219	121.43	11/18/96
	A12	6,020,035	2/1/00	Gupta, et al.	427	534	10/29/96
	A13	6,029,718	2/29/00	Jackson, et al.	141	231	6/26/98
	A14	6,109,206	8/29/00	Maydan, et al.	118	723IR	5/29/97
	A15	6,159,333	12/12/00	Gupta, et al.	156	345	10/8/98
	A16	6,255,222	7/3/01	Xia, et al.	438	710	8/24/99
	A17	6,264,852	7/24/01	Herchen, et al.	216	60	6/16/00
	A18	6,271,148	8/7/01	Kao, et al.	438	727	10/13/99
<i>yn</i>	A19	6,352,081	3/5/02	Lu, et al.	134	22.1	7/9/99

EXAMINER

neer yon neyzen

DATE CONSIDERED

12/09/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RECEIVED

FORM PTO 1449 US Department of Commerce
Patent and Trademark Office

ATTY DOCKET NO.:

FOC1100-1

SERIAL NO.:

10/038,745

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

APPLICANT(S):

Robert Jackson

FILING DATE:

January 2, 2002

GROUP ART UNIT

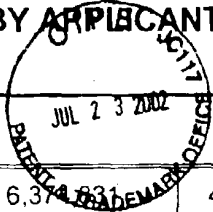
1754

PATENT NO. OF PARENT:

n/a

ISSUE DATE OF PARENT

n/a



RECEIVED
TC 1700
8 7 2002

you	A20	6,374,831	4/23/02	Chandran, et al.	134	1.1	2/4/99
	A21	6,379,575	4/30/02	Yin, et al.	216	67	10/21/97
	A22	6,387,288	5/14/02	Bjorkman, et al.	216	67	4/21/00
you	A23	2002/0074013A1 09/741,529	published 6/20/02	Shang, et al.	134	1.1	12/19/00

FOREIGN PATENT DOCUMENTS

EXAM. INITIALS		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES/NO)
you	B1	EP0697467A1	21.02.1996	Europe	C23C	16/44	Yes
	B2	WO 99/06611	11.02.1999	WO	C23C	16/44	Yes
	B3	WO 99/28538	10.06.1999	WO	C25B	9/00	Yes
	B4	EP0965661A2	22.12.1999	Europe	C25B	9/00	Yes
you	B5	EP1076355A2	14.02.2001	Europe	H04L	21/00	Yes

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

you	C1	<i>Kinetics of Gaseous Fluorine Reactions</i> , by Rudy Toon and Myron Kaufman. Progress in Reaction Kinetics, 1975, Vol. 8, No. 2, pp. 81-93					
you	C2	VLSI Technology, Sze, Section 8.3 - Dry Etching, McGraw-Hill Book Co., pp. 312-317 (1983)					
you	C3	MKS ASTeX® Products Announces ASTRON®e Ser High Flow Reactive Gas Generators for Process Chamber Cleaning Applications, Information printed from website www.astex.com/prastrone.html (2001)					

EXAMINER

you [signature]

DATE CONSIDERED

12/09/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.